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CONFIRMATION NO. 2840

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|-----------------------------|---------------------------------------|--------------|------------------------|--|
| SERIAL NUMBER 10/670,163 | FILING DATE 09/23/2003 RULE | CLASS 438 | GROUP ART UNIT 2811 | ATTORNEY DOCKET NO. 1613370-0019 DIV |
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APPLICANTS

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** CONTINUING DATA *****
 This application is a DIV of 10/186,375 06/27/2002 PAT 6,677,172 *yes on*

** FOREIGN APPLICATIONS ***** *NONE on*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
 ** 12/19/2003

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|---|---------------------------|------------------------|-----------------------|----------------------------|
| Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no | STATE OR COUNTRY NM | SHEETS DRAWING 4 | TOTAL CLAIMS 42 | INDEPENDENT CLAIMS 4 |
|---|---------------------------|------------------------|-----------------------|----------------------------|

35 USC 119 (a-d) conditions met
☐ yes ☒ no ☐ Met after Allowance

Verified and Acknowledged
 Examiner's Signature *[Signature]* Initials

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TITLE
 On-wafer burn-in of semiconductor devices using thermal rollover

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|------------|---|--|
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